



Serial No. 10/712,100

SKI.008C2

Request for Reconsideration dated January 31, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Shunji Hayashi

Group Art Unit: 2125

Serial No.: 10/712,100

Examiner: K. Bahta

Filed: November 14, 2003

Confirm No.: 8230

For: METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR
MANUFACTURING EQUIPMENT

REQUEST FOR RECONSIDERATION

U.S. Patent and Trademark Office
Customer Window, Mail Stop AF
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Date: January 31, 2006

Sir:

In response to the Final Office Action dated November 3, 2005, the following
remarks are respectfully submitted in connection with the above-identified application.

Remarks/Arguments begin on page 2 of this paper.